

Application News

Gas Chromatography

Analysis of SF₆ Insulation Gas Using a GC-BID System

No. **G300A**

Sulfur hexafluoride (SF₆) is an extremely stable gas with excellent dielectric properties and is used in various fields. Applications include tracer gas as well as insulation gas used in electrical equipment such as gas-insulated transformers and circuit breakers. On the other hand, SF₆ is also known to be a highly potent greenhouse gas and was identified as an emission reduction target in the Kyoto Protocol at the COP3 meeting. Conventional analysis of SF₆ employs an electron capture detector (ECD) which is capable of detecting electrophilic compounds with high sensitivity. However, the quantitation accuracy in the high-concentration range and the hassle of procedures necessary due to the use of radioisotopes have been an issue. Shimadzu's barrier discharge ionization detector (BID) offers high-sensitivity detection of almost all components. Utilizing proprietary barrier discharge technology, the detector achieves both the same stability as general conventional detectors and high sensitivity.

This article introduces example analyses of SF_6 and SF_6 decomposition products.

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■ Analysis of Impurities in SF₆

 SF_6 is used as an insulation gas in various electrical equipment and requires purity analysis for quality control to maintain insulation properties and when recycling the gas. Fig. 1 shows the result of analyzing impurities in SF_6

using a BID. The primary component SF₆ is saturated, but did not influence the quantitation accuracy of surrounding components, showing that high-sensitivity batch analysis of impurities including inorganic gas and lower hydrocarbons was successful. (Under the analytical conditions using this type of column, C₂H₆ is overlapped by SF₆.)

The concentrations of impurities found in the SF_6 sample are as follows.

Table 1 Measurement Conditions

 Model
 : Nexis™ GC-2030

 Detector
 : BID-2030

 Inj. Mode
 : Split 1:4

 Inj.Temp.
 : 150 °C

Carrier Gas : 7 mL/min (constant flow rate)
Column : MICROPACKED-ST 2.0 m × 1.0 mm I.D.

(Input 250 m \times 0.50 mm I.D. and df = 10 μm for flow

rate calculation)

Column Temp. : 35 °C (2.5 min) – 20 °C/min – 250 °C (0 min) –

15 °C/min – 265 °C (3.0 min)

 Purge flow
 : 3 mL/min

 Det. Temp.
 : 280 °C

 Discharge Gas
 : 50 mL/min (He)

 Inj. Volume
 : 3.0 mL (MGS-2030)

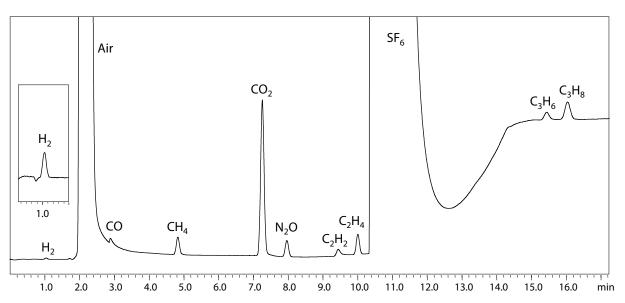


Fig. 1 Analysis of Impurities in SF₆

Analysis of Trace SF₆ in the Atmosphere

Since SF₆ is a potent greenhouse gas and its emission into the atmosphere must be avoided, leak tests for insulation gas from electrical equipment and residue tests after collecting gas may require analysis of trace amounts of SF₆. Table 2 lists the measurement conditions and Fig. 2 shows the result of analyzing trace SF₆ in the atmosphere.

SF₆ at a concentration of 0.1 ppm was detected $(S/N = 24^{*1})$ and favorable linearity was obtained in the range from 0.1 to 50 ppm ($R^2 = 0.9998$).

*1 Determined by calculating noise from the baseline between 0.5 and 1.5 min.

Table 2 Measurement Conditions

: Nexis ™ GC-2030 Model BID-2030 Detector Inj. Mode Split 1:7 lnj.Temp. 150 °C

Carrier Gas 45 cm/sec (constant linear velocity)

SH-Msieve 5A (0.53 mm I.D.×30 m, d.f.50 μm) *1 Column Column Temp. 35 °C (2.5 min) – 20 °C/min – 250 °C (0 min)

15 °C/min – 270 °C (3.42 min)

Purge flow 3 ml /min 280°C Det. Temp. Discharge Gas 50 mL/min (He) 3.0 mL (MGS-2030) Inj. Volume

^{*1} P/N: 221-75763-30

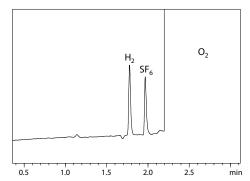


Fig. 2 Analysis of Trace SF₆ (0.1 ppm) in the Atmosphere

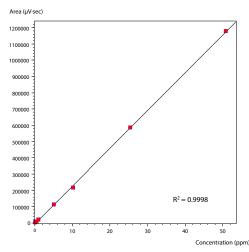


Fig. 3 Linearity of SF₆ in the Atmosphere (0.1 to 50 ppm)

■ Analysis of SF₆ Decomposition Gas

SF₆ is used as an insulation gas in circuit breakers. Breakers are installed on electrical grids to shut off high voltages that may occur due to causes such as lightning strikes. When performing maintenance on such breakers, SF₆ decomposition gases are analyzed to judge the degradation level of insulation gas. Table 3 lists the measurement conditions and Fig. 4 shows the results of an example analysis of CF₄ and SOF₂ which are SF₆ decomposition gases. Sample injection using a gas sampler and a gas-tight syringe is possible on the same system, allowing analysis of gas samples in various forms and concentrations.

Table 3 Measurement Conditions

Nexis[™] GC-2030 Model Detector Inj. Mode BID-2030 Split 1:4 150 °C Ini.Temp.

Carrier Gas 7 mL/min (constant flow rate) MICROPACKED-ST 1.0 m \times 1.0 mm l.D. Column

(Input 1,250 m \times 0.50 mm I.D. and df = 15 μ m for

flow rate calculation)

50 °C (1.0 min)– 25 °C/min – 150 °C (0 min) – 5 °C/min – 200 °C (0 min) Column Temp. :

Purge flow 3 mL/min

Det. Temp. 280°C Discharge Gas 50 mL/min (He)

Inj. Volume 200 µL (gas-tight syringe)

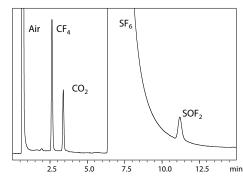


Fig. 4 Analysis of SF₆ Decomposition Gases (CF₄: 310 ppm, SOF₂: 107 ppm)

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